

Contents

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Diffraction Optics

Diffraction Elements for Imaging Optical Systems <i>A. I. Antonov, G. I. Greisukh, E. G. Ezhov, and S. A. Stepanov</i>	421
Features of Optical Surfaces of Multifocal Diffraction-Refractive Eye Lenses <i>G. A. Lenkova</i>	431
Processes for Manufacturing Multifocal Diffraction-Refractive Intraocular Lenses <i>I. A. Iskakov</i>	442
Application of Diffraction Elements for Improving the Efficiency of Systems for Cylindrical Surface Inspection <i>P. S. Zavyalov, V. E. Karlin, M. S. Kravchenko, L. V. Finogenov, and D. R. Khakimov</i>	450
Diffraction Focusing Fan-Out Element for the Parallel DNA Sequencer <i>V. P. Bessmeltsev, P. S. Zavyalov, V. P. Korolkov, R. K. Nasyrov, and V. S. Terentyev</i>	457
Study of the Optical Methods of Formation of Multilevel Profile in the Thin Films of a Hybrid Photopolymer Material Based on Thiol-Siloxane and Acrylate Oligomers <i>N. G. Mironnikov, V. P. Korolkov, D. I. Derevyanko, and V. V. Shelkownikov</i>	466
Laser Technologies in Micro-Optics. Part 1. Fabrication of Diffraction Optical Elements and Photomasks with Amplitude Transmission <i>V. P. Veiko, V. P. Korolkov, A. G. Poleshchuk, D. A. Sinev, and E. A. Shakhno</i>	474

Optical Information Technologies

Nonparaxial Effects in Lensacon Optical Systems <i>N. L. Kazanskiy and S. N. Khonina</i>	484
Fourier Optics of Constant-Thickness Three-Dimensional Objects on the Basis of Diffraction Models <i>Yu. V. Chugui</i>	494
Comparison of the Energy Characteristics of Tightly Focused Needle Beams with Longitudinal Polarization <i>A. G. Sedukhin</i>	508

Interference Systems and Devices

- Manufacturing and Certification of a Diffraction Corrector for Controlling the Surface Shape of the Six-Meter Main Mirror the Big Azimuthal Telescope of the Russian Academy of Sciences
R. K. Nasyrov and A. G. Poleshchuk 517
- Interferometric Method for Controlling the Assembly Quality of an Optical System with an Eccentrically Arranged Aspheric Lens
R. K. Nasyrov, A. G. Poleshchuk, M. N. Sokol'skii, and V. P. Tregub 524
- Automated Interference Tools of the All-Russian Research Institute for Optical and Physical Measurements
G. N. Vishnyakov, G. G. Levin, and V. L. Minaev 530
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